Form PTO-1449 U.S. DEPARTMENT OF COMMERCE Atty. Docket No. Serial No. (REV. 7-80) PATENT AND TRADEMARK OFFICE PHN 17,819 09/745,914 Applicant ANTONIUS H.M. RAAIJMAKERS ET AL. Filing Date INFORMATION DISCLOSURE CITATION Group (Use several sheets if necessary) 12.22.00 **U.S. PATENT DOCUMENTS** Ex. Document Date Name Clas Sub-Filing Date Int Number s clas If Approp. S AΑ AB AC AD ΑE AF FOREIGN PATENT DOCUMENTS Sub-Document Date Country Class Trans. Number clas s No Yes AG AΗ ΑI ΑJ AΚ OTHER (Including Author, Title, Date, Pertinent Pages, Etc.) "Large area image sensing using amorphous silicon nip diodes" by N.C. Bird, C.J. ALCurling and C. van Bergel in Sensors and Actuators a 46-47 (1995) 444-446. AM AN Date Considered Examiner *EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPER Draw line through citation if not in conformance and not considered. Include a copy this form with next communication to applicant.

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